



# EeonTex™ nonwoven pressure sensing fabric

**EeonTex™ NW170-SLPA-2k** is a conductive nonwoven with piezo-resistive functionality. It is used for dynamic sensors to map and measure pressure, bend, angle stretch and torsion.



Pressure sensors replace buttons, slides and dials on this MIDI controller by [Keith McMillen Instruments](#)

Part number:	<b>EeonTex™ NW170-SLPA-2k</b>
Surface resistivity:	2K ohms/ square
Dynamic range:	5g-100kg
Data acquisition rate:	500 cycles per second
Density:	170 g/m <sup>2</sup>
Thickness:	0.80 mm